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Product Datasheet

Resolute[®] RCC MU

Implementation of Membrane Chromatography Based on Rapid Cycling Chromatography (RCC)

Product Information

The Resolute® RCC MU is a liquid chromatography system intended for small scale production and process development in purification of biomolecules. Designed to achieve optimum purification of mAbs, ADCs, vaccines, viral vectors, and recombinant proteins, the system provides a tailored design and configuration for the implementation of membrane chromatography based on Rapid Cycling Chromatography (RCC). Compared to traditional and multi-column chromatography in mAb bioprocessing, RCC offers extremely high productivity and enables a consistent performance together with Sartobind® membrane chromatography products. This optimized skid addresses the challenges of running many cycles in a short time – with fast flow rates, rapid buffer changes, data handling and real time analytics powered by Umetrics® and supported by full-spectrum pre-post UV.



Features and Benefits

| Features | Benefits | RCC Solution (Optimized system, device membrane) |
|--|--|---|
| Small footprint (700 × 1,000 × 1,830 mm) Two modes for bind-elute and flow-through Rotatable HMI, keyboard and touchscreen | Easier Installation and operation for new facilities | Flexibility |
| Positive displacement pump with low pulsation Small void volume (overall system: 190 mL) Defined fluid inlet: Mixing point of feed and buffer lines close to the membrane adsorber | Efficient processing by quick ramp-up, less back mixing and concentration dilution | Time and cost saving |
| Optimized valve with very short switching time: 0.5 s Full-spectrum UV sensors | Reliable process control and advanced analytics | Consistency of product quality |
| Real-time monitoring and prediction | | |

Technical Specifications

System Specifications

by Umetrics®

| Description | Specification |
|--|--|
| Version | Main module (Batch configuration) |
| Footprint (W \times L \times H) | 700 × 1000 × 1830 mm |
| Weight | 300 kg |
| Hold-up olume | < 200 mL (without bubble trap) |
| Electrical cabinet location | Embedded |
| Distance between electrical cabinet & the system (only when remote cabinet option is selected) | N/A (Electrical cabinet is embedded onto the pumping module) |
| Distance between electrical cabinet & the supervision (only when remote supervision option is selected) | N/A (Supervision is embedded onto the pumping module) |
| Automation device location | In the electrical cabinet |
| HMI display location | Embedded onto the skid |
| | |

Operating Environment

| Description | Specification | |
|---------------------------|--------------------------------|--|
| Ambient temperature range | 10-25 °C | |
| Humidity | 20% to 70% Rh (non-condensing) | |

Enclosure Protection Class

| Description | Specification |
|--|-----------------|
| Main electrical cabinet Electrical protection classes | IP55 (EN-60529) |
| Field mounted electrical parts Electrical protection classes | IP66 (EN-60529) |

Electrical Requirements

| Description | Specification | |
|--|---|------------------|
| Version | North American version | European version |
| Voltage type AC/DC | AC | AC |
| Nominal power supply | 208Y 120V | 230V |
| Frequency | 60 Hz | 50 Hz |
| Power required | 2 kW | 2 kW |
| Phase numbers | 3 phases | 1 phase |
| Switching current capacity (kA r.m.s) | N/A | 55 |
| Short-circuit current rating SCCR (kA) | 10 | N/A |
| Neutral system distributed | Wye phases midpoint grounded with neutral | TN-S |

Technical Specifications

Process Utilities Requirements

| Specification | |
|---|--|
| | |
| Operating pressure: 5 bar max Inlets: 0.15 barge max Outlets: >0 and <1 bar | |
| 5 to 150 L/h (83 to 2500 mL/min) | |
| >2 µm filtered | |
| Operating span: 4-50 °C | |
| | |
| 6-7 bar | |
| <5 Nm³/h | |
| 40 µm filtered, oil free & dry | |
| 10-30 °C | |
| | |

Interface Requirements

| Туре | Description |
|--------------------------------|-----------------------|
| Instrumentation compressed air | 10 mm push-in fitting |
| Buffers and feed Inlets | ¾″ Micro-Clamp® |
| Collection valves | ¾″ Micro-Clamp® |
| Membrane connection | ¾″ Micro-Clamp® |

Material of Construction

| Description | Specification |
|-------------------------------------|--|
| Tubing material | Polypropylene, stainless steel 316L |
| Frame | Stainless steel 304, painted stainless steel (powder coating) |
| Gasket Material & other Wetted Part | PPSU Radel [®] , stainless steel (316L), quartz, glass, ceramic, PP, PTFE, PEEK, EPDM, EPDM-PP or platinum silicon |
| Electrical cabinet | Painted stainless steel (powder coating) |
| Tubing internal roughness | Electro polished <0.6 µm Ra (71 µ-inches Ra) |
| Valves internal roughness | N/A |
| Pumps internal roughness | Electro polished <0.6 µm Ra (71 µ-inches Ra) |
| Frame external roughness | Grit 200 (about 1.6 µm Ra (62 µ-inches Ra) |
| Pipe & Welding specification | Refer to SCE URS CC-866 |
| Passivation procedure | Refer to SCE URS CC-1078 & CC-1042 |
| Insulation | No |
| Tagging | Color: silver Material: polyester with solvent resistant protective film |

Standards & Norms

| Description | Specification |
|--|---|
| Electrical design | EC Machine Directive EC Low Voltage Directive EC Electro Magnetic Compatibility Directive RoHS Directive Registration, Evaluation, Authorization and Restriction of Chemicals (REACH) |
| Explosion proof design (Depending of the selected options) | Not designed for hazardous area |
| Material certificates for wetted parts | 3.1 for stainless steel FDA USP Class VI for polymers |
| Software & automation standards | GAMP guidelines and FDA CFR 21 Part 11 regulations |
| Tagging | English language. Compliant with UL/CSA, 2005/618/EC MCV amendment to RoHS Directive 2002/95/EC |
| Documentation provided | Refer to SCE Quality Plan 1SO-MANL |

Technical Specifications

Selection of Membrane Adsorbers

Bind-Elute

| Sartobind® Q and S | | |
|--|---------------|---------------|
| Membrane volume (MV) | 150 mL | 400 mL |
| Nominal membrane area | 5,500 cm² | 14,600 cm² |
| Bed height | 8 mm | 8 mm |
| Design | Cylindrical | Cylindrical |
| Maximum pressure bar (MPa, psig) at 20 °C | 4 (0.4, 58) | 4 (0.4, 58) |
| Maximum pressure during venting bar (MPa, psig) at 20 °C | 0.5 (0.05, 7) | 0.5 (0.05, 7) |
| Sartobind® Phenyl | | |
| Membrane volume (MV) | 150 mL | 400 mL |
| Nominal membrane area | 5,500 cm² | 14,600 cm² |
| Bed height | 8 mm | 8 mm |
| Design | Cylindrical | Cylindrical |
| Maximum pressure bar (MPa, psig) at 20 °C | 4 (0.4, 58) | 4 (0.4, 58) |
| Maximum pressure during venting bar (MPa, psig) at 20 °C | 0.5 (0.05, 7) | 0.5 (0.05, 7) |
| Flow-Through | | |
| Sartobind® Q and S | | |
| Membrane volume (MV) | 75 mL | 200 mL |
| Nominal membrane area | 2,700 cm² | 7,300 cm² |
| Bed height | 4 mm | 4 mm |
| Design | Cylindrical | Cylindrical |
| Maximum pressure bar (MPa, psig) at 20 °C | 4 (0.4, 58) | 4 (0.4, 58) |
| Maximum pressure during venting bar (MPa, psig) at 20 °C | 0.5 (0.05, 7) | 0.5 (0.05, 7) |
| Sartobind STIC® PA | | |
| Membrane volume (MV) | 75 mL | 200 mL |
| Nominal membrane area | 2,700 cm² | 7,300 cm² |
| Bed height | 4 mm | 4 mm |
| Design | Cylindrical | Cylindrical |
| Maximum pressure bar (MPa, psig) at 20 °C | 4 (0.4, 58) | 4 (0.4, 58) |
| Maximum pressure during venting bar (MPa, psig) at 20 °C | 0.5 (0.05, 7) | 0.5 (0.05, 7) |
| | | |

Ordering Information

| Configuration | Description | | Order Number |
|---|---|--------------------------------|----------------------------|
| Capture The Resolute [®] RCC MU system can be mechanically and electrically configured as a patch to be used for capture. | Feed Line 4 Inlets, 1 Air Sensor, 1 Pump A, 1 Flowmeter, 1 Pressure Post Pump A, 1 Pressure Post Pre-Filter, 1 pH/Cd Pre-Membrane, 1 Air Sensor Pre-Membrane, 1 UV Pre-Membrane, 1 Membrane w/ Bypass, 1 pH/Cd Post-Membrane, 1 pressure Post-Membrane, 1 UV Post-Membrane, 4 Fractions | Capture CE Capture UL | MCSCEB46NAK MCSULB46NAK |
| | Buffer Line 6 Inlets, 1 Air Sensor, 1 Pump B (Gradient/ILD), 1 Flowmeter, 1 Pressure Post Pump B, 1 SCE Display | | |
| Flow-Through | 1 Pressure Post Pre-Filter, 1 Air Sensor Pre-Membrane, | Flow-Through CE | MCSCEB4NNAK |
| he Resolute® RCC MU system an be mechanically and electrically configured as a batch to be used for polishing. | | Flow-Through UL | MCSULB4NNAK |
| Feed LineCapture with Bubble Trap4 Inlets, 1 Air Sensor, 1 Pump A, 1 Flowmeter, 1 Pressure Post Pump A, 1 Pressure Post Pre-Filter, 1 PH/Cd Pre-Membrane, 1 Air Sensor Pre-Membrane, 1 UV Pre-Membrane, 1 UV Pre-Membrane, 1 Membrane w/ Bypass, 1 pH/Cd Post-Membrane, 1 Pressure Post-Membrane, 1 UV Post-Membrane, 1 UV Post-Membrane, 4 FractionsBuffer Line 6 Inlets, 1 Air Sensor, 1 Pump B (Gradient/ILD), 1 Flowmeter, 1 SCE Display, 1 Bubble trap | Capture with Bubble Trap CE | MCSCEB46AAK | |
| | 1 pH/Cd Pre-Membrane, 1 Air Sensor Pre-Membrane, 1 UV Pre-Membrane, 1 Membrane w/ Bypass, 1 pH/Cd Post-Membrane, 1 Pressure Post-Membrane, | Capture with Bubble Trap UL | MCSULB46AAK |
| | 6 Inlets, 1 Air Sensor, 1 Pump B (Gradient/ILD), 1 Flowmeter, 1 Pressure Post Pump B, | | |

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